

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. .... 09/814,260  
Filing Date ..... March 21, 2001  
Inventor ..... Scott E. Moore et al.  
Assignee ..... Micron Technology, Inc.  
Group Art Unit ..... 3723  
Examiner ..... T. Eley  
Attorney's Docket No. .... MI22-1663  
Title: "Semiconductor Workpiece Processing Methods, A Method of Preparing  
Semiconductor Workpiece Process Fluid, and A Method of Delivering  
Semiconductor Workpiece Process Fluid to a Semiconductor Processor"

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

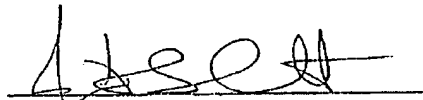
References -- See Attached Form PTO-1449

The attached form PTO-1449 is submitted in compliance with 37 CFR §1.56. No admission is made regarding whether all the submitted references are prior art.

Respectfully submitted,

Dated: 12/15/05

Attorney:

  
James D. Shaurette  
Reg. No. 39,833

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Sheet 1 of 1

Form PTO-1449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. MI22-1663		SERIAL NO. 09/814,260	
LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)				APPLICANT Scott E. Moore et al.			
				FILING DATE March 21, 2001		GROUP 3723	
U.S. PATENT DOCUMENTS							
*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
	AA	5,446,531	8/29/1995	Boyer et al.			
	AB	6,319,469B1	11/20/2001	Mian et al.			
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						
	AL						
FOREIGN PATENT DOCUMENTS							
		Document Number	Date	Country	Class	Subclass	Translation
							Yes No
	AM						
	AN						
	AO						
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)							
	AP						
EXAMINER				DATE CONSIDERED			
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							

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